



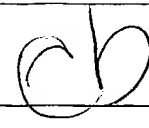
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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/943,806	08/30/2001	Andrew D. Bailey III	LAM1P124D1	4355
22434	7590	05/05/2004	EXAMINER	
BEYER WEAVER & THOMAS LLP P.O. BOX 778 BERKELEY, CA 94704-0778			ALEJANDRO MULERO, LUZ L	
			ART UNIT	PAPER NUMBER
			1763	

DATE MAILED: 05/05/2004

Please find below and/or attached an Office communication concerning this application or proceeding.

<p align="center"><b>Office Action Summary</b></p>	<p>Application No.</p> <p>09/943,806</p>	<p>Applicant(s)</p> <p>BAILEY ET AL. </p>	
	<p>Examiner</p> <p>Luz L. Alejandro</p>	<p>Art Unit</p> <p>1763</p>	

**-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --**

**Period for Reply**

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
  - If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely.
  - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
  - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133).
- Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

**Status**

- 1) ☒ Responsive to communication(s) filed on 08 March 2004.
- 2a) ☐ This action is **FINAL**.                      2b) ☒ This action is non-final.
- 3) ☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

**Disposition of Claims**

- 4) ☒ Claim(s) 23,26,27,32,33 and 35-49 is/are pending in the application.
- 4a) Of the above claim(s) \_\_\_\_\_ is/are withdrawn from consideration.
- 5) ☐ Claim(s) \_\_\_\_\_ is/are allowed.
- 6) ☒ Claim(s) 23,26,27,32,33 and 35-49 is/are rejected.
- 7) ☐ Claim(s) \_\_\_\_\_ is/are objected to.
- 8) ☐ Claim(s) \_\_\_\_\_ are subject to restriction and/or election requirement.

**Application Papers**

- 9) ☐ The specification is objected to by the Examiner.
- 10) ☐ The drawing(s) filed on \_\_\_\_\_ is/are: a) ☐ accepted or b) ☐ objected to by the Examiner.
- Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).
- Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).
- 11) ☐ The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

**Priority under 35 U.S.C. § 119**

- 12) ☐ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
- a) ☐ All    b) ☐ Some \* c) ☐ None of:
1. ☐ Certified copies of the priority documents have been received.
2. ☐ Certified copies of the priority documents have been received in Application No. \_\_\_\_\_.
3. ☐ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).

\* See the attached detailed Office action for a list of the certified copies not received.

**Attachment(s)**

- |                                                                                                                                                                                                                                                                                                                   |                                                                                                                                                                                                                                         |
|-------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|-----------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|
| <p>1) <input checked="" type="checkbox"/> Notice of References Cited (PTO-892)</p> <p>2) <input type="checkbox"/> Notice of Draftsperson's Patent Drawing Review (PTO-948)</p> <p>3) <input type="checkbox"/> Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08)</p> <p>Paper No(s)/Mail Date _____.</p> | <p>4) <input type="checkbox"/> Interview Summary (PTO-413)</p> <p>Paper No(s)/Mail Date. _____.</p> <p>5) <input type="checkbox"/> Notice of Informal Patent Application (PTO-152)</p> <p>6) <input type="checkbox"/> Other: _____.</p> |
|-------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|-----------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|

## **DETAILED ACTION**

### ***Continued Examination Under 37 CFR 1.114***

A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after final rejection. Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, the finality of the previous Office action has been withdrawn pursuant to 37 CFR 1.114. Applicant's submission filed on 3/8/04 has been entered.

### ***Claim Rejections - 35 USC § 112***

The following is a quotation of the first paragraph of 35 U.S.C. 112:

The specification shall contain a written description of the invention, and of the manner and process of making and using it, in such full, clear, concise, and exact terms as to enable any person skilled in the art to which it pertains, or with which it is most nearly connected, to make and use the same and shall set forth the best mode contemplated by the inventor of carrying out his invention.

Claims 23, 26-27, 32, and 46-47 are rejected under 35 U.S.C. 112, first paragraph, as failing to comply with the written description requirement. The claim(s) contains subject matter which was not described in the specification in such a way as to reasonably convey to one skilled in the relevant art that the inventor(s), at the time the application was filed, had possession of the claimed invention. The specification, as originally filed, fails to provide support for "wherein the thermal blocks are not thermally coupled to the coil".

***Claim Rejections - 35 USC § 103***

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negated by the manner in which the invention was made.

This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

Claims 23, 26-27, 32, 42-43, and 46-47 are rejected under 35 U.S.C. 103(a) as being unpatentable over Collins et al., EP 0 837 489 A2 in view of Collins, U.S. Patent 6,361,644.

Collins et al. shows the invention substantially as claimed including a method for providing temperature control to a plasma processing chamber of a plasma processing apparatus, the method comprising: directly and indirectly measuring temperature internal to the plasma processing chamber 40 using a temperature sensor 76, for instance, to measure the temperature of the ceiling 52 and using a temperature sensor

79 to measure the temperature of the ring 62; comparing both of these temperatures to a target temperature (see page 12-line 54 to page 13-line 17); heating the plasma processing chamber by heating a thermal control block including a heater element 75 coupled to the plasma processing chamber 52 through a conformal thermal interface 1090, a cooling element 74 (see figs. 18-19), and a thermal break 1085 (see figs. 20-21) that is thermally coupled and biased to the plasma processing chamber 40 (see page 13-line 55 to page 14-line 22); cooling the plasma processing chamber 40 by actively cooling the thermal control block 74,75, wherein there are layers (thermal break element) in the block separating the heating element from the cooling element (see Figs. 17A-23); and wherein the thermal control block further include notches (1000, 1020) through which gas flows and which prevent RF energy from coupling with the thermal control block (see figs. 18-19). Furthermore, note that the heating and cooling are provided through the same thermal control block 74,75 (claim 24).

Collins et al. fails to expressly disclose a plurality of thermal control blocks. However, a prima facie case of obviousness exists because the duplication of parts have been held to have been obvious (see *In re Harza*, 274 F.2d 669, 124 USPQ 378 (CCPA 1960)). Furthermore, it would have been obvious to one having ordinary skill in the art at the time the invention was made to have a plurality of thermal control blocks in the apparatus of Collins et al. because this allows for better controllability over the process being conducted in the apparatus.

Collins et al. fails to expressly disclose that the plurality of thermal control blocks are located around the sides of the plasma processing chamber. However, a prima

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facie case of obviousness exists because the rearrangement of parts have been held to have been obvious (see *In re Japikse* 86 USPQ 70 (CCPA 1950)). Furthermore, it would have been obvious to one having ordinary skill in the art at the time the invention was made to have a plurality of thermal control blocks in the apparatus of Collins et al. because this allows for better controllability over the process being conducted in the apparatus.

Furthermore, Collins et al. fails to expressly disclose that the thermal control blocks are not thermally coupled to the coil. Collins discloses a thermal control block containing a heating element 510 and cooling element 520 that are not coupled to the coil 145 (see figs. 26-29 and their description). In view of this disclosure, it would have been obvious to one of ordinary skill in the art at the time the invention was made to modify the process of Collins et al. so as to not couple the thermal block to the coil as suggested by Collins because this will serve to insulate the antenna and reduce temperature fluctuations of the antenna.

Concerning claim 43, apparatus limitations, unless they affect the process in a manipulative sense, have little weight in process claims. *In re Tarczy-Hornoch* 158 USPQ 141, 150 (CCPA 1968); *In re Edwards* 128 USPQ 387 (CCPA 1961); *Stalego v. Heymes* 120 USPQ 473, 478 (CCPA 1959); *Ex parte Hart* 117 USPQ 193 (PO BdPatApp 1957); *In re Freeman* 44 USPQ 116 (CCPA 1940); *In re Sweeney* 72 USPQ 501 (CCPA 1947).

Claims 33, 35-41, 44-45, and 48-49 are rejected under 35 U.S.C. 103(a) as being unpatentable over Collins et al., EP 0 837 489 A2 in view of Collins, U.S. Patent 6,572,372.

Collins et al. shows the invention substantially as claimed including a method for providing temperature control to a plasma processing chamber of a plasma processing apparatus, the method comprising: directly and indirectly measuring temperature internal to the plasma processing chamber 40 using a temperature sensor 76, for instance, to measure the temperature of the ceiling 52 and using a temperature sensor 79 to measure the temperature of the ring 62; comparing both of these temperatures to a target temperature (see page 12-line 54 to page 13-line 17); heating the plasma processing chamber by heating a thermal control block including a heater element 75 coupled to the plasma processing chamber 52 through a conformal thermal interface 1090, a cooling element 74 (see figs. 18-19), and a thermal break 1085 (see figs. 20-21) that is thermally coupled and biased to the plasma processing chamber 40 (see page 13-line 55 to page 14-line 22); cooling the plasma processing chamber 40 by actively cooling the thermal control block 74,75, wherein there are layers (thermal break element) in the block separating the heating element from the cooling element (see Figs. 17A-23); and wherein the thermal control block further include notches (1000, 1020) through which gas flows and which prevent RF energy from coupling with the thermal control block (see figs. 18-19).

With respect to claim 39, note that the heating and cooling are provided through the same thermal control block 74,75.

Collins et al. fails to expressly disclose a plurality of thermal control blocks. However, a prima facie case of obviousness exists because the duplication of parts have been held to have been obvious (see *In re Harza*, 274 F.2d 669, 124 USPQ 378 (CCPA 1960)). Furthermore, it would have been obvious to one having ordinary skill in the art at the time the invention was made to have a plurality of thermal control blocks in the apparatus of Collins et al. because this allows for better controllability over the process being conducted in the apparatus.

Collins et al. fails to expressly disclose that the plurality of thermal control blocks are located around the sides of the plasma processing chamber. However, a prima facie case of obviousness exists because the rearrangement of parts have been held to have been obvious (see *In re Japikse* 86 USPQ 70 (CCPA 1950)). Furthermore, it would have been obvious to one having ordinary skill in the art at the time the invention was made to have a plurality of thermal control blocks in the apparatus of Collins et al. because this allows for better controllability over the process being conducted in the apparatus.

Collins et al. does not expressly disclose that the cooling is provided by the cooling element through the heating element, the thermal break, and the conformal thermal interface and into the chamber. Collins discloses a method for providing temperature control to a plasma processing chamber by which a cooling element 520 cools the chamber through heating element 510 that is in physical contact with a roof (147,400,110) (see figs. 26-29 and their descriptions). Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to modify



the teachings of Collins et al. as to perform the cooling through the heating element, the thermal break, and the conformal thermal interface because this is a suitable method for controlling the temperature of the plasma chamber. Additionally, the particular arrangement of the cooling and heating means, which will provide for the cooling through the heating member, would not lend patentability to the instant application without the showing of unexpected results.

Regarding claim 45, note that both the thermal break and the conformal thermal interface can be formed of a variety of materials (see page 15, line 50 to page 16, line 8 of Collins et al.). In view of this disclosure, it would have been obvious to one of ordinary skill in the art at the time the invention was made to determine through routine experimentation the optimum thermal conductivity of the thermal break and conformal thermal interface based upon a variety of factors including the speed at which it is desired to control the temperature of the chamber or the desired thermal separation between the heating block and cooling element, and such limitation would not lend patentability to the instant invention absent the showing of unexpected results.

Concerning claims 44 and 48-49, apparatus limitations, unless they affect the process in a manipulative sense, have little weight in process claims. In re Tarczy-Hornoch 158 USPQ 141, 150 (CCPA 1968); In re Edwards 128 USPQ 387 (CCPA 1961); Stalego v. Heymes 120 USPQ 473, 478 (CCPA 1959); Ex parte Hart 117 USPQ 193 (PO BdPatApp 1957); In re Freeman 44 USPQ 116 (CCPA 1940); In re Sweeney 72 USPQ 501 (CCPA 1947). Moreover, note from fig. 20 of Collins et al., for instance,

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the presence of notches in the cold plate and notches in the hot plate overlying the coil such that the notches are parallel to each other.

### ***Response to Arguments***

Applicant's arguments filed 3/8/04 have been fully considered but they are not persuasive. Applicant argues that the coil in the instant invention is spaced apart from the thermal blocks and is therefore not thermally coupled to the thermal blocks. The examiner respectfully disagrees since a) as discussed in the above rejection under 35 USC 112, first paragraph, the specification, as originally filed, does not disclose the limitation of "wherein the thermal blocks are not thermally coupled to the coil", and b) there is not sufficient evidence that the spacing between the coil and the thermal control blocks is in an amount such that thermal coupling does not occur.

Furthermore, applicant contends that a conformal thermal interface is not shown in the reference. In response, applicant is directed to reference number 1090 in fig. 20 which shows such a conformal thermal interface.

With respect to applicant's statements that the references fail to show placing the thermal blocks against one portion of the roof and the coils against another portion of the roof, the combination of references properly reject these claims since the claim does not exclude the coil and the thermal blocks from being against common portions of the roof.


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**Conclusion**

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Luz L. Alejandro whose telephone number is 571-272-1430. The examiner can normally be reached on Monday to Thursday from 7:30 to 6:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Gregory L. Mills can be reached on 571-272-1439. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

  
Luz L. Alejandro  
Primary Examiner  
Art Unit 1763

May 3, 2004